Docket Number: 081468-0306526 Client Reference: P-1598.010-US

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Re the Application of

intonius T.A.M. DERKSEN et al.

Group Art Unit:

Application No.: 10/705,785

Examiner: Unassigned

Filed: November 12, 2003

Confirmation No.: Unassigned

For: Lithographic Apparatus and Device Manufacturing Method

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents P. O. Box 1450 Alexandria, VA 22313-1450

Sir:

Pursuant to 37 C.F.R. 1.56, the attention of the Patent and Trademark Office is hereby directed to the following U.S. patent application(s):

Examiner's Initials	Inventor	Application No.	Filing Date	Enclosed
All Presents			\$16000 Yes 22	
	Joeri LOF et al.	10/705,805	11/12/2003	 ☑ Specification ☑ Drawings ☑ Other: stamped receipt card
	Joeri LOF et al.	10/705,783	11/12/2003	
	Helmar Van SANTEN et al.	10/743,271	12/23/2003	
	Johannes C.H. MULKENS et al.	10/743,266	12/23/2003	
	Joannes T. DESMIT et al.	10/705,804	11/12/2003	 ✓ Specification ✓ Drawings ✓ Other: stamped receipt card
	Klaus SIMON	10/724,402	12/01/2003	☒ Specification☒ Drawings☒ Other: stamped receipt card
	Arno J. BLEEKER	10/715,116	11/18/2003	
	Bob STREEFKERK et al.	10/719,683	11/24/2003	
	Joeri LOF et al.	10/705,816	11/12/2003	☒ Specification☒ Drawings☒ Other: stamped receipt card

The Examiner's initials indicates he/she has considered the cited application relative to the subject application.

It is respectfully requested that these applications and the art cited therein during examination be expressly considered during the prosecution of this application and be made of record in this application. The identification of the above U.S. patent applications is not to be construed as a waiver of secrecy as to those applications now or upon issuance of the present application as a patent.

<u>PLEASE DO NOT PRINT</u> the above information on the patent which results from this application.

Consideration of each listed application is earnestly solicited since unpublished patent applications are contemplated as IDS material; see the exception in Rule 98(a)(2)(iii) and note the penultimate sentence of MPEP 609.

Further, in keeping with MPEP 609, subsec. C(2), 2nd para., line 10 to end of the paragraph (especially note lines 18-25) **PLEASE RETURN A COPY OF THIS LETTER** with the Examiner's initials adjacent each above listing so that applicant will know that each listed application has been considered as required by PTO policy.

Secondly, please consider each enclosed document which is listed on the attached Form PTO-1449 and return a copy of that form with the Examiner's initials adjacent each citation. It is respectfully requested that these documents listed on the Form PTO-1449 be expressly considered during the prosecution of this application, and that the documents be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

This Information Disclosure Statement is being filed before the mailing date of the first Office Action on the merits in the present application. No certification or fee is required.

Respectfully Submitted,

Jean-Paul G. Hoffman Registration Number 42663 Customer Number: 00909

Date: February 20, 2004

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Facsimile: (703) 905-2500

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